



**HEWLETT-PACKARD COMPANY**  
Intellectual Property Administration  
P.O. Box 272400  
Fort Collins, Colorado 80527-2400

Docket No.: 10002929-3  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re Patent Application of:  
Jeffrey C. Swanson et al.

Application No.: 10/670,620

Confirmation No.: 6729

Filed: September 25, 2003

Art Unit: 2113

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For: A SYSTEM AND METHOD FOR MULTIPLE  
CYCLE CAPTURE OF CHIP STATE

Examiner: M. C. Maskulinski

**RESPONSE ACCOMPANYING**  
**REQUEST FOR CONTINUED EXAMINATION**

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

**INTRODUCTORY COMMENTS**

This Response and RCE follows withdrawal of an appeal by Applicant in favor of further prosecution. Please reconsider the rejections for the above-identified U.S. patent application in view of the remarks contained herein.

**A Listing of the Claims** are reflected in a list which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 5 of this paper.